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**Confirmation Letter**

To,
Ugalal P Shinde
Published in      : Volume 8 | Issue 8 | 2021-08-24

**Subject:** Publication of paper at International Journal of Emerging Technologies and Innovative Research .

Dear Author,

With Greetings we are informing you that your paper has been successfully published in the International Journal of Emerging Technologies and Innovative Research (ISSN: 2349-5162). Following are the details regarding the published paper.

About JETIR    : An International Scholarly Open Access Journal, Peer-Reviewed, Refereed Journal Impact Factor Calculate by Google Scholar and Semantic Scholar | AI-Powered Research Tool, Multidisciplinary, Monthly, Multilanguage Journal Indexing in All Major Database & Metadata, Citation Generator, Impact Factor: 7.95, ISSN: 2349-5162

UGC Approval  : UGC and ISSN Approved - UGC Approved Journal No: 63975 | Link: https://www.ugc.ac.in/journallist/subjectwisejurnallist.aspx?tid=MjM0OTUxNjI=&&did=U2VhcmNoIGJ5IElllTU04=

Registration ID : JETIR  314270

Paper ID         : JETIR2108448

Title of Paper   : STUDY OF ELECTRICAL AND GAS SENSING PROPERTIES OF THERMALLY EVAPORATED NICKEL OXIDE THIN FILMS

Impact Factor   : 7.95 (Calculate by Google Scholar)

DOI                : http://doi.one/10.1729/Journal.27950

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Authors          : Ugalal  P Shinde, Rajendra S Gosavi

Thank you very much for publishing your article in JETIR. We would appreciate if you continue your support and keep sharing your knowledge by writing for our journal JETIR.

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